

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
Shinji MAEKAWA et al. )  
Application No. 10/575,492 ) Art Unit: 2812  
Filed: April 12, 2006 ) Confirmation No. 3788  
For: METHOD FOR FORMING WIRING, METHOD )  
FOR MANUFACTURING THIN FILM TRANSISTOR )  
AND DROPLET DISCHARGING METHOD )

INFORMATION DISCLOSURE STATEMENT

United States Patent and Trademark Office  
Customer Window, Mail Stop AMENDMENT  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. In accordance with the policies of the U.S. Patent and Trademark Office, only copies of newly cited foreign patents and non-patent literature are being submitted.

The Japanese references cited on the attached PTO-1449 were cited by the Japanese Patent Office in the counterpart Japanese Patent Application No. 2004-311157 in an Office Action mailed June 22, 2010.

Further, Applicants wish to note that U.S. Patent Nos. 6,808,972; 6,905,906; 7,098,061; 7,176,040; 7,572,651; and 7,635,857, U.S. Patent Publication No. 2006/0286726 and International Publication Nos. WO2001/046987; WO2001/047043; WO2001/047044; and WO2001/047045 are in the same family as JP 2003-518756. These family documents were not cited in the above-noted Office Action.

The undersigned certifies (with the exception of the family documents noted above) that each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent

office in connection with a counterpart foreign application not more than three (3) months prior to the filing of this statement.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fee required in connection with this filing, and any additional fees which may be required, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

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